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## BIB DATA SHEET

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10/576,321	04/19/2006	438	1722	12054-0059

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP04/11050 08/02/2004

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2003-360251 10/21/2003

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\***

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Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					
Verified and Acknowledged	/MARISSA W CHAET/ Examiner's Signature	Initials	JAPAN	5	8	1

**ADDRESS**

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**TITLE**

Process for producing high-resistance silicon wafers and process for producing epitaxial wafers and soi wafers (as amended)

FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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